

Homework #7 - EE 531

due 6/5/09

1. (Second chance) You are told by your process engineers that they can control doping concentration within $\pm 5\%$ and channel dimensions within $\pm 0.02\mu\text{m}$.

- (a) Given these process variations, design an NMOS transistor with an n^+ poly gate ($\phi_{poly} \cong \chi_s$), 4nm thick oxide, deep source/drains, a very shallow threshold-shifting implant, and otherwise constant substrate doping to minimize the worst-case switching time under the constraint that the worst-case off-state leakage current is less than $1\text{nA}/\mu\text{m}$ (with $V_{GS} = 0\text{V}$ and including DIBL). Assume that the power supply voltage is 2V (set to limit gate field to 5MV/cm) and that the switching speed can be approximated by

$$W [4LC'_{ox} + (0.5\mu\text{m})C'_j] V_{dd}/I_{DS},$$

(C'_j is junction capacitance for S and D) where I_{DS} is calculated from Eq. 3.76 for $V_{GS} = V_{DS} = 2\text{V}$ and $V_{SB} = 0$. You have control over the substrate doping, implant dose (to shift V_T , ignore effect on mobility), and channel dimensions L and W . Use Eq. 3.66 in the text for short channel effects and DIBL and the model for channel length modulation from Eq. 3.97 (use $\mathcal{E}_{sat} = 2\mathcal{E}_c$, $v_{sat} = 8 \times 10^6$ cm/s). Use value of effective mobility calculated at the source.

- (b) Test your design using Sentaurus Device (remember to use worst-case analysis). You can modify the example used in previous homework. Suggest possible reasons for significant discrepancies. Test the switching speed first by just determining I_{DS} . Then use an output load consisting of a capacitor equal to $4WLC'_{ox}$ (fan-out of 4 equivalent transistors) in a transient simulation. Initialize the capacitor with a voltage equal to 2V and determine the time to discharge down to 0.5 V (roughly V_T).

- i. Plot the mobility as limited by ionized impurity scattering versus temperature for doping of 10^{16}cm^{-3} and 10^{18}cm^{-3} in silicon. Rather than integrating over all possible k values, you can instead use an average value of k for the given temperature ($KE = 3k_B T/2$). Assume the scattering is within a single minima which can be approximated to be spherically symmetric with a single effective mass $(m_l m_t^2)^{1/3}$. What is the approximate power law dependence?
- ii. Plot the mobility versus doping at room temperature. Comment on your results.

2. Problem 4.10 in Taur and Ning.

3. Problem 5.4 in Taur and Ning.